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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP98/04983 11/05/1998

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 9-319059 11/05/1997  
JAPAN 10-207198 07/07/1998

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> Met after Allowance	JAPAN	DRAWING 4	8	4
Verified and Acknowledged	Examiner's Signature _____ Initials _____				

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## TITLE

METHOD OF FORMING SEMICONDUCTOR WIRING STRUCTURES.

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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